

# Small Volume Plating System & Handheld Substrate Holder

For optimizing electroplating solutions NBT has designed a testing cell for volumes less than three liters. Working with such small quantities during the development process of electrolytes or etchants allows the variation of different compounds without wasting large amounts of material.

The cell is made of transparent PVC and resistant to various chemicals. It has two chambers each with a separate drain tap.

If temperature controlling (up to 60°C) is required, the cell fits in a special heating bath.

The substrate holder made of PEEK can be construed for different wafer sizes (e. g. 100 mm SEMI standard). The backside of the wafer stays dry using closed-cell EPDM foam. The edge exclusion on the front side is less than 5 mm. There are options for front side and backside contacts.

For electroplating applications insoluble anodes (platinized titanium) or specific soluble anodes (e. g. Ni, Cu, Sn) can be used.

It is possible to integrate a high-power LED field with light control unit for light induced plating (LIP).

## Applications

- Wet chemical processes e. g. etching
- Electroplating
- Anodization
- Porosification of silicon

## Main benefits

- Single side/backside dry processing
- Substrate holders for changing the wafer size or contacting configuration
- Light induced or supported processes



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## Small volume test cells

For substrates up to 200 mm

Outer dimensions (incl. valves and fittings):

- w 240 mm x l 295 mm x h 210 mm

Weight: 2.2 kg

Volume:

- Tank 1: max 4.4 l, for operation 3.4 l
- Tank 2: max 3.4 l, for operation 2.6 l

Material: transparent PVC; PVC valves

## Heating bath

Temperature control: up to 60°C

Permissible ambient temp.: 5°...40°C

Power supply: 230V~ 50/60Hz

Current max.: 10 A

Heating capacity: 2 kW

Recommended heating fluid: 15 l Water

Outer dimensions (incl. valves and fittings):

- w 520 mm x l 450 mm x h 350 mm

Materials: transparent PVC; PVC valves;  
stainless steel heating tubes

## Handheld substrate holders

For substrates up to 200 mm

Outer dimensions (incl. handle and screws):

- w 193 mm x l 243 mm x h 24 mm

Weight: 470 g

Wafer geometry:

- 100 mm, 150 mm, 200 mm SEMI
- 125 mm PV square
- 156 mm PV square
- Or custom design

Materials: PEEK; gold contacts

